

Comparative ellipsometric and ion beam analytical studies on ion beam crystallized silicon implanted with Zn and Pb ions
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Solid phase and ion beam epitaxial crystallization of Si implanted with Zn and Pb ions

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https://www.researchgate.net/publication/289467840_Solid_phase_and_ion_beam_epitaxial_crystallization_of_Si_implemented_with_Zn_and_Pb_ions